

### **AMENDMENTS TO THE SPECIFICATION**

On page 1, paragraph [0001], immediately below the heading "CROSS REFERENCE TO RELATED APPLICATIONS," please replace with the following new paragraph:

[0001] This application is a divisional of, and claims priority under 35 U.S.C. § 120 from, U.S. Patent Application Serial No. 10/159,238, filed May 31, 2002, and still pending, which is related to commonly-assigned and co-filed U.S. Patent Application Serial No. 10/160,625, filed May 31, 2002, entitled "Method For Producing Vertical Tapers In Optical Waveguides By Over Polishing" by M. Salib, and to U.S. Patent Application Serial No. 10/159,379, filed May 31, 2002, entitled "Fabrication Of A Waveguide Taper Through Ion Implantation" by M. Salib *et al.*